



1/14

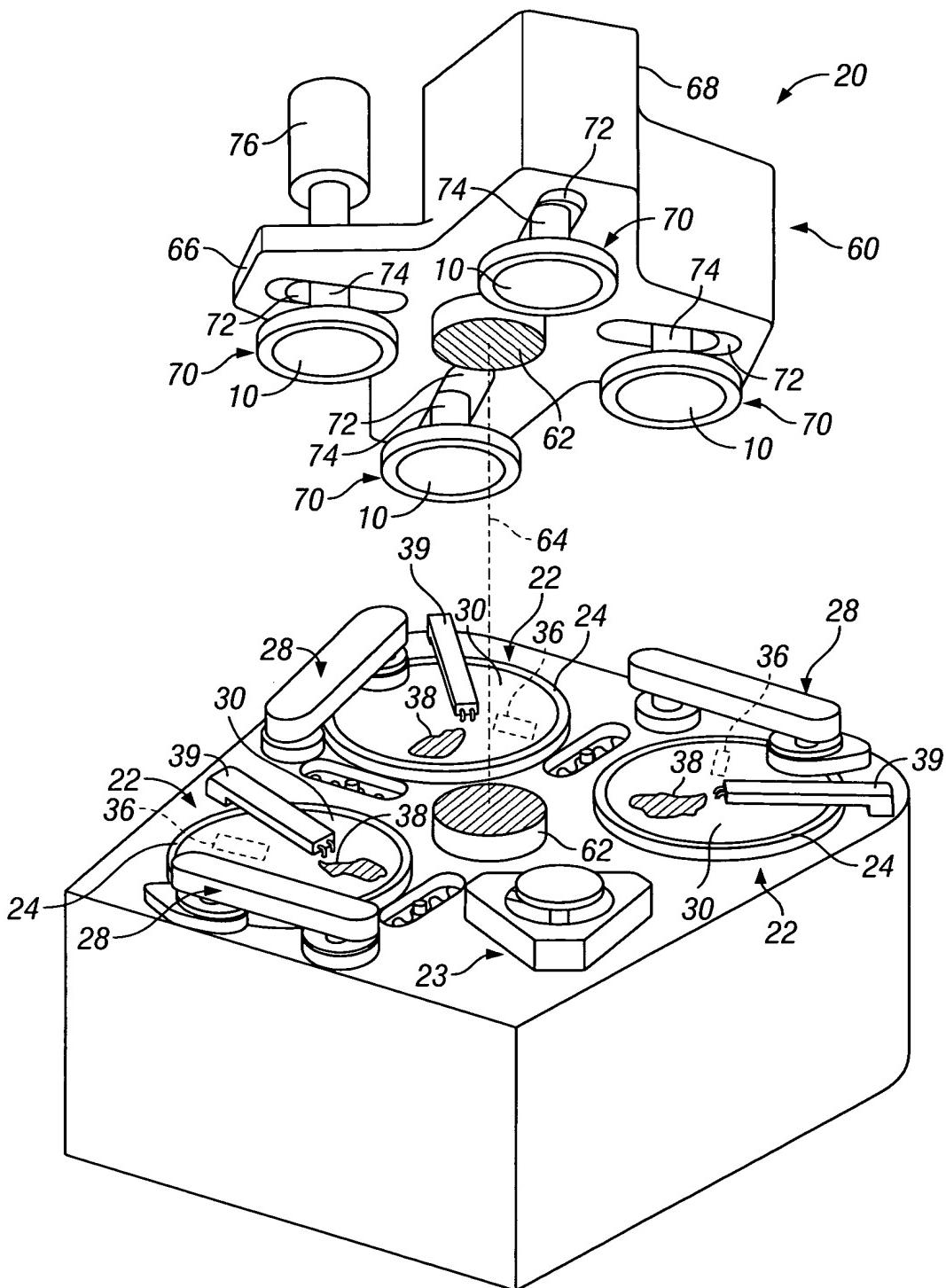


FIG. 1

Applicant(s): Doyle E. Bennett et al.  
CHEMICAL MECHANICAL POLISHING APPARATUS WITH  
NON-CONDUCTIVE ELEMENTS  
REPLACEMENT SHEET

2/14

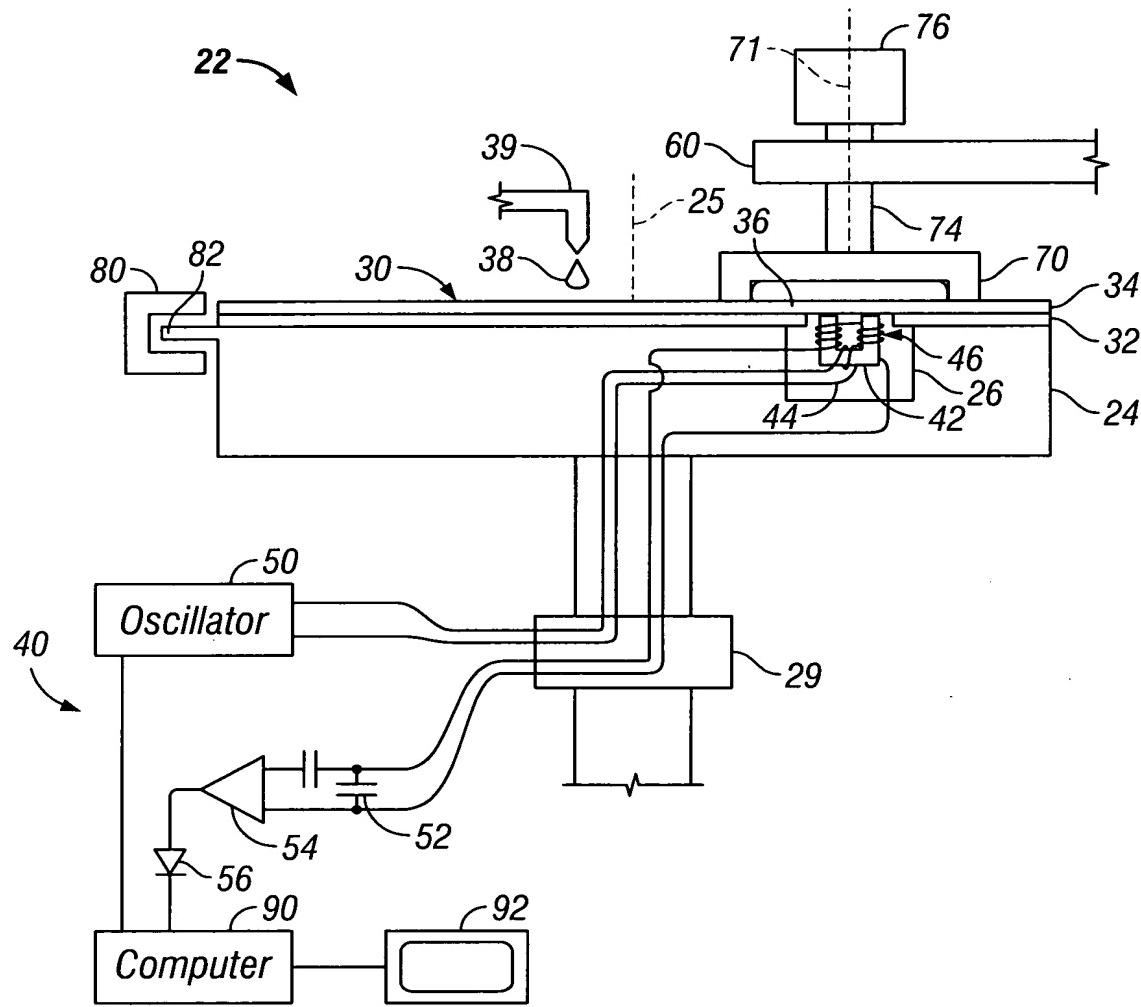
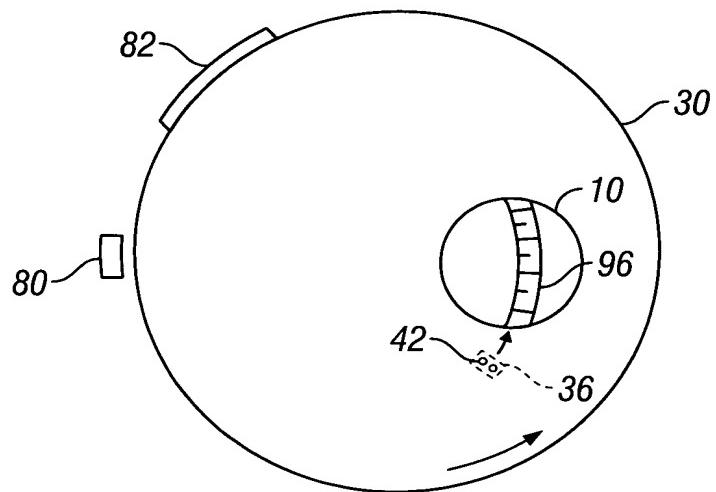
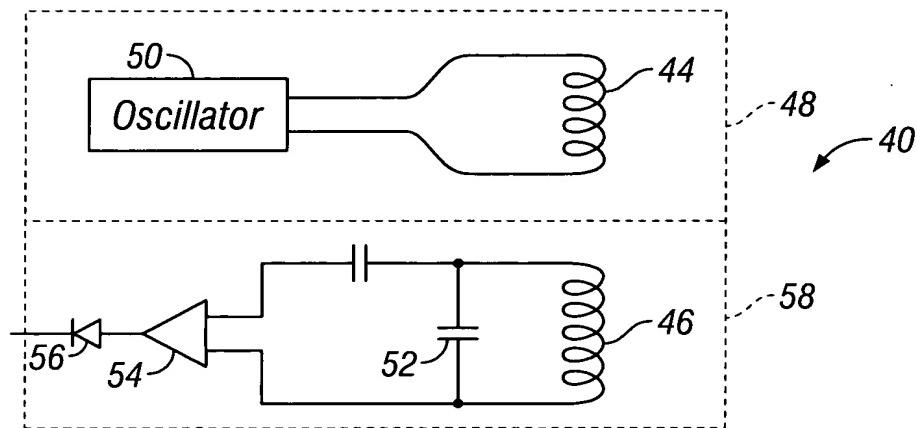
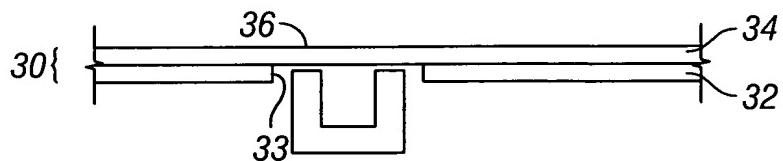
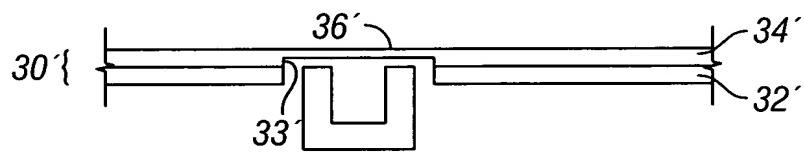
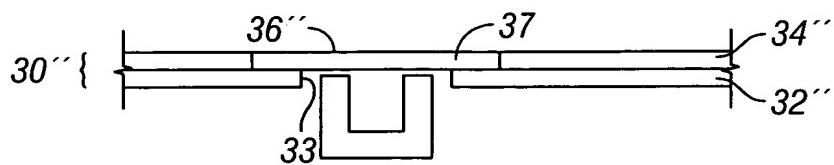


FIG. 2A

**3/14****FIG. 2B****FIG. 3**

**4/14****FIG. 4A****FIG. 4B****FIG. 4C**

5/14

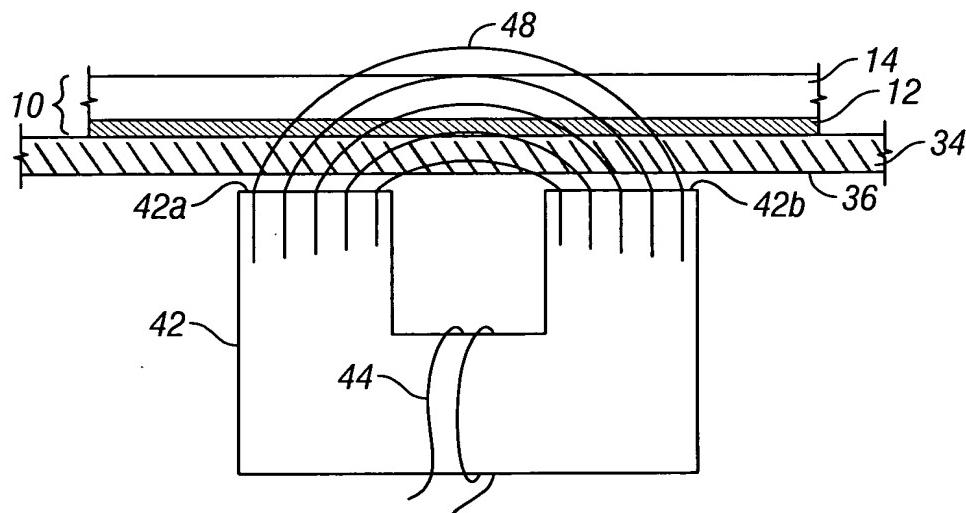


FIG. 5

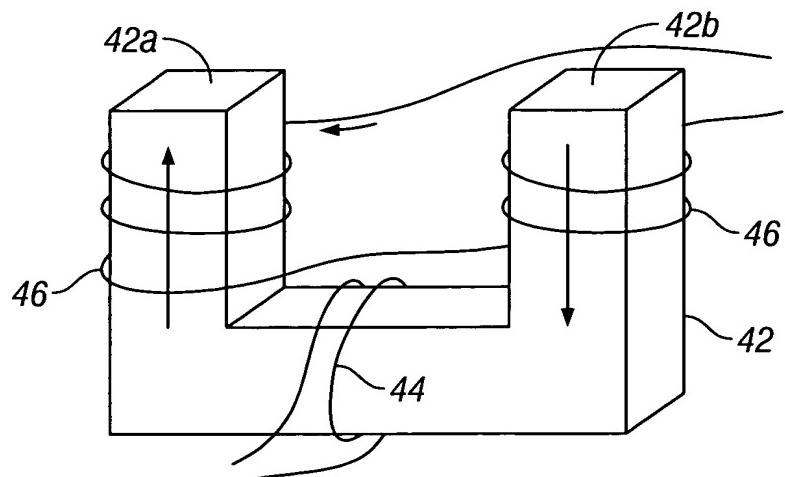


FIG. 6

6/14

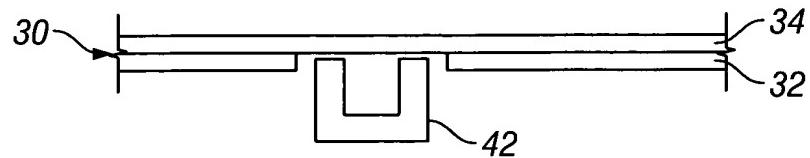


FIG. 7A

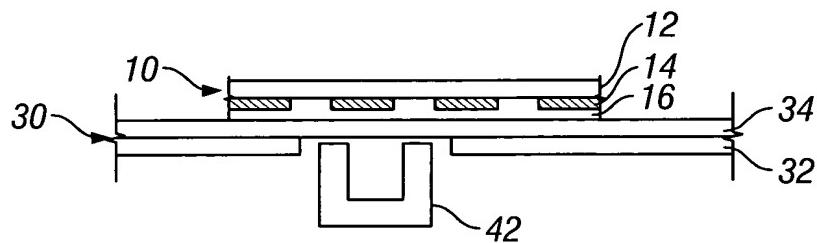


FIG. 7B

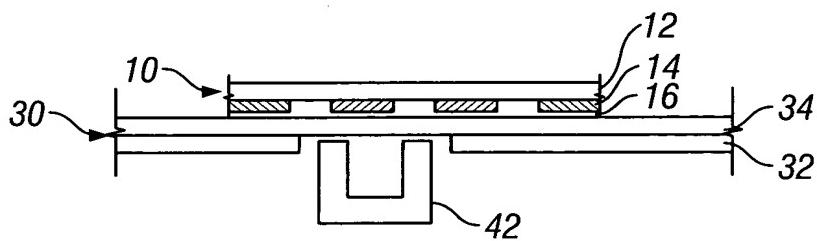


FIG. 7C

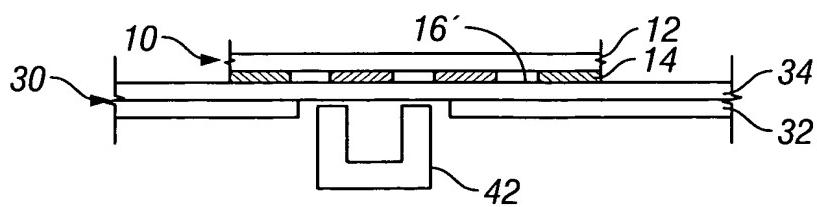


FIG. 7D

7/14

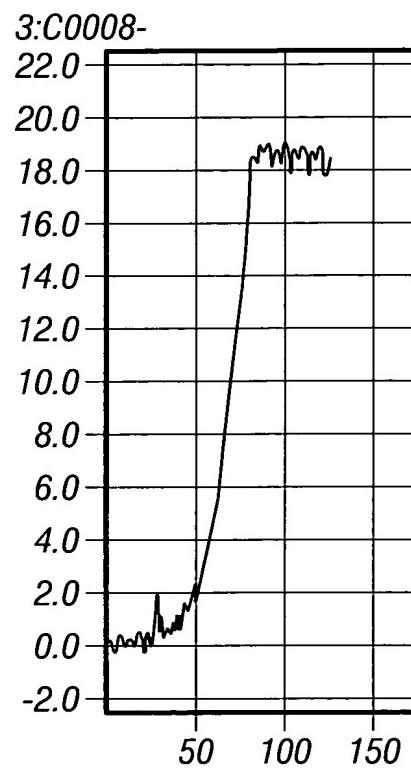


FIG. 8

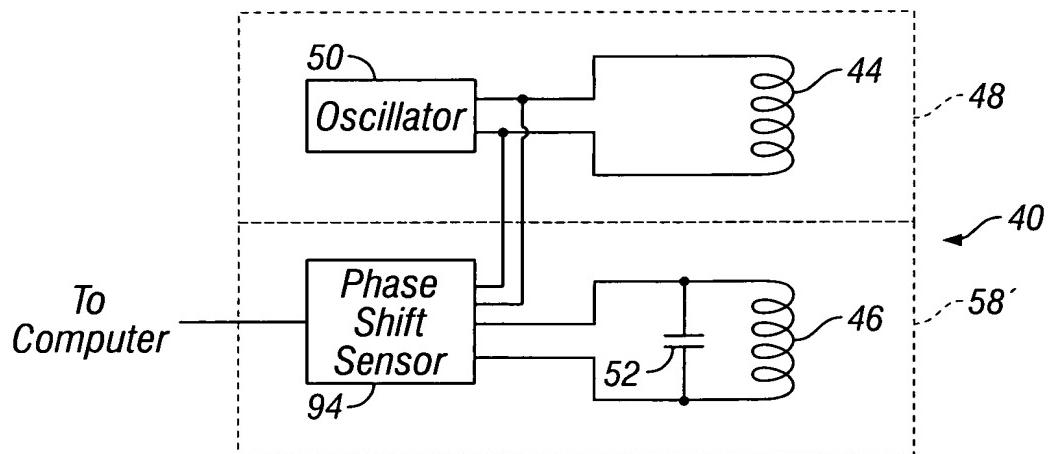
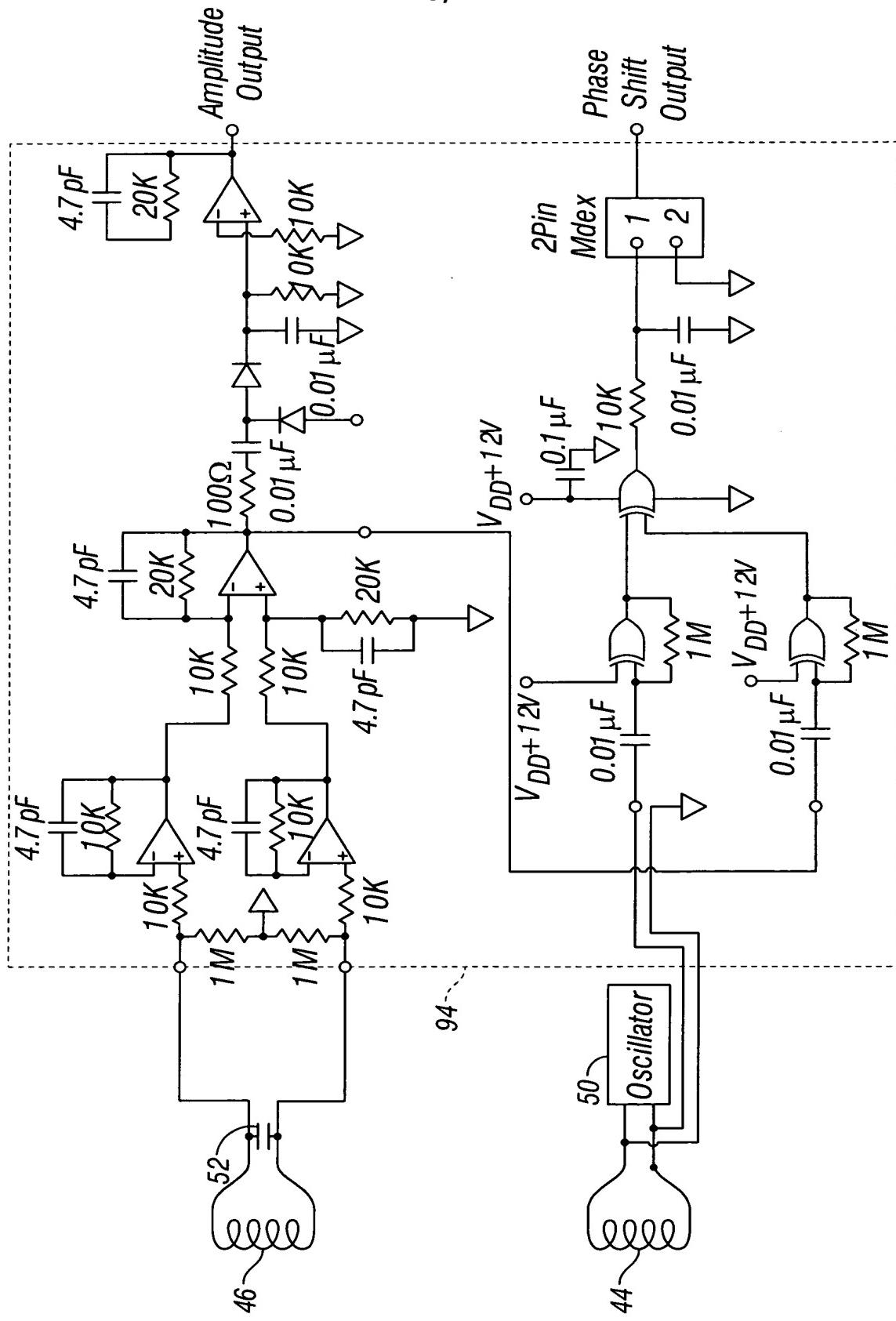


FIG. 9

8/14

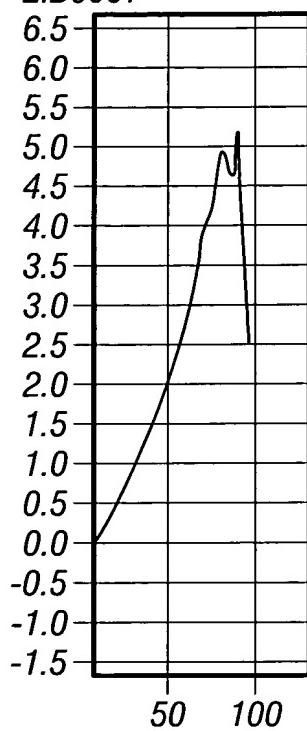
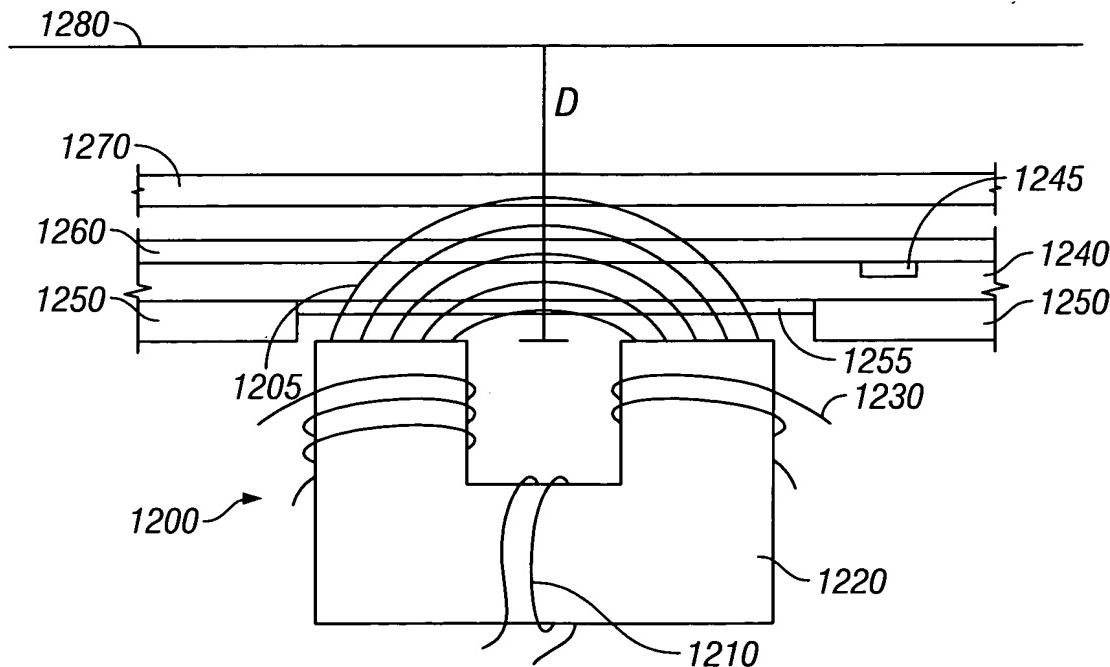


**FIG. 10A**



**10/14**

2:B0007-

**FIG. 11****FIG. 12**

## **REPLACEMENT SHEET**

# CHEMICAL MECHANICAL POLISHING APPARATUS WITH NON-CONDENSABLE ELEMENTS

## NON-CONDUCTIVE ELEMENTS

#### **REPLACEMENT**

11/14

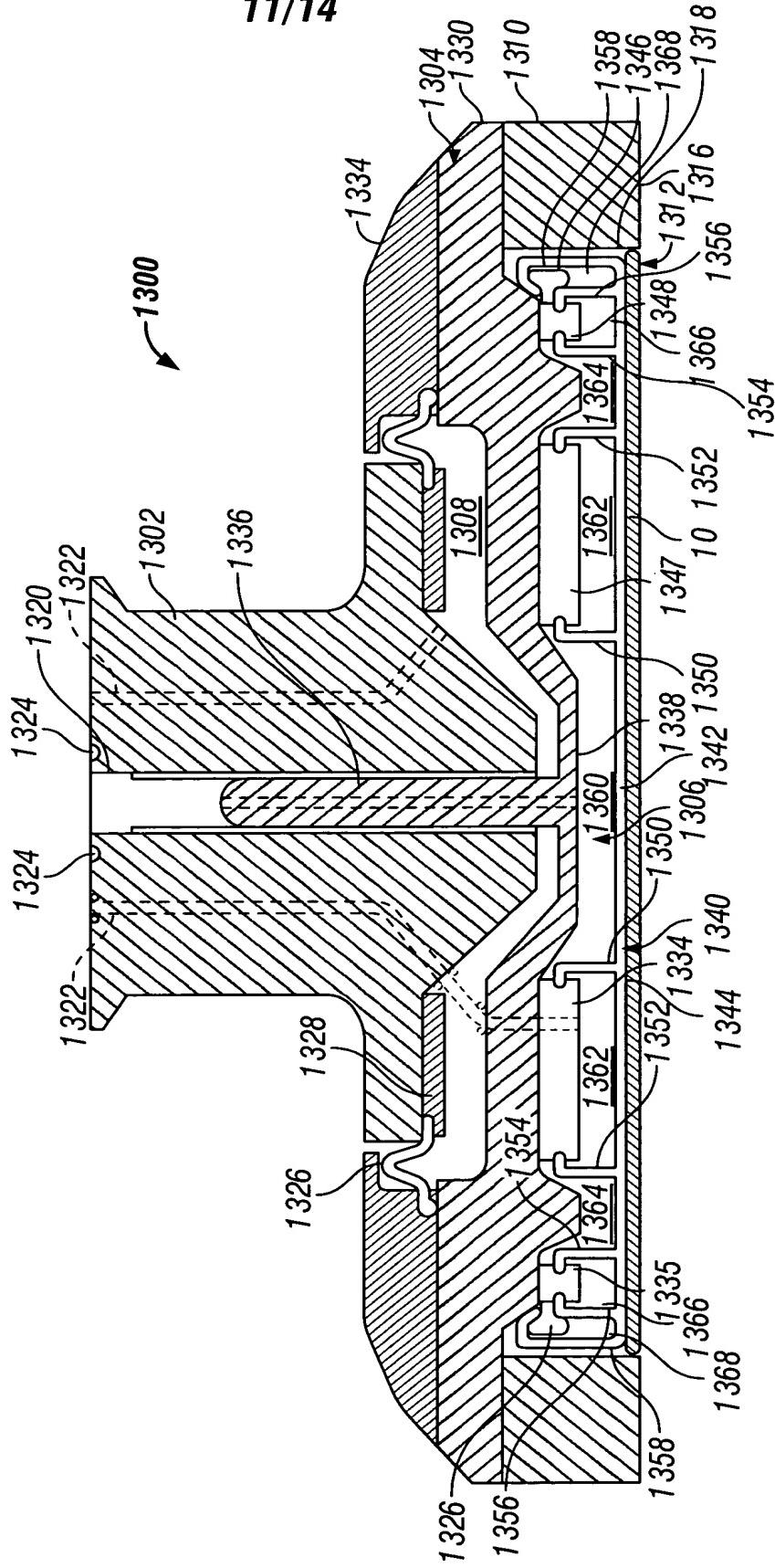


FIG. 13

12/14

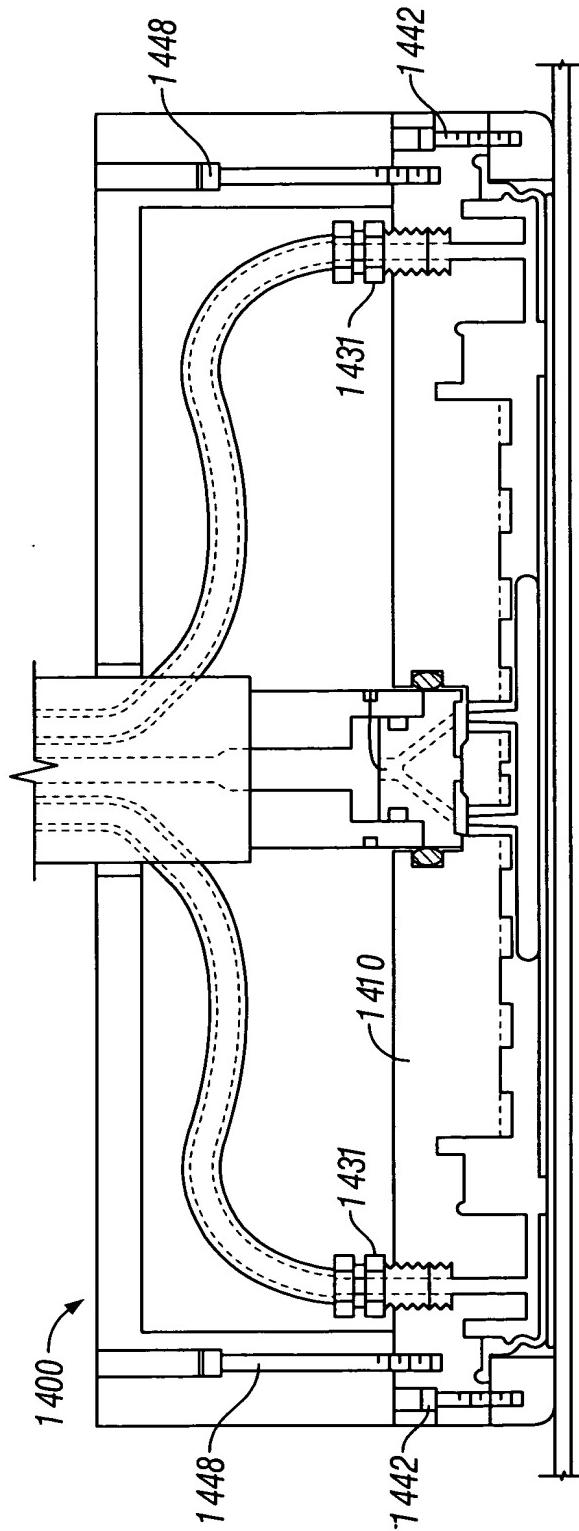
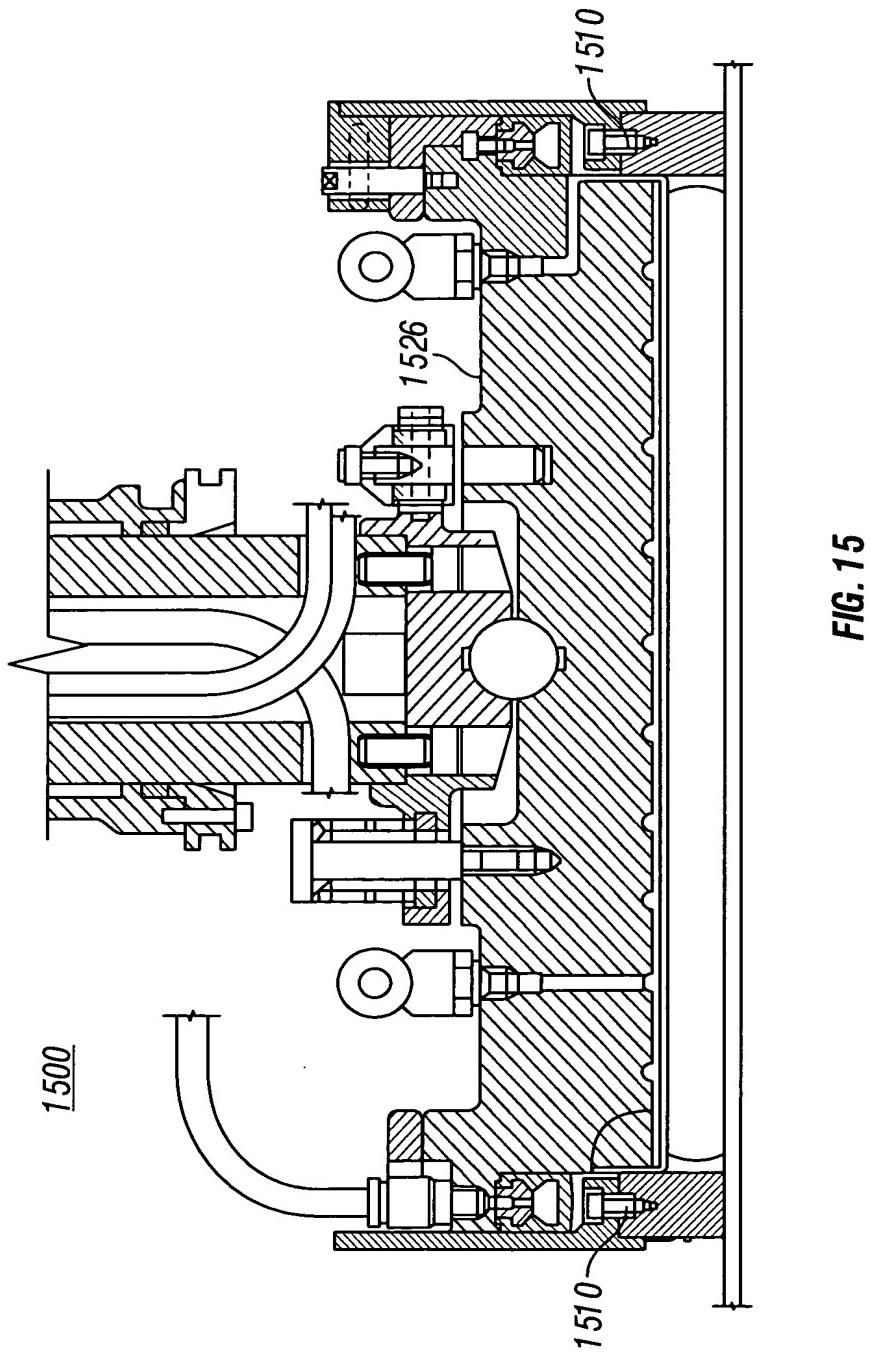
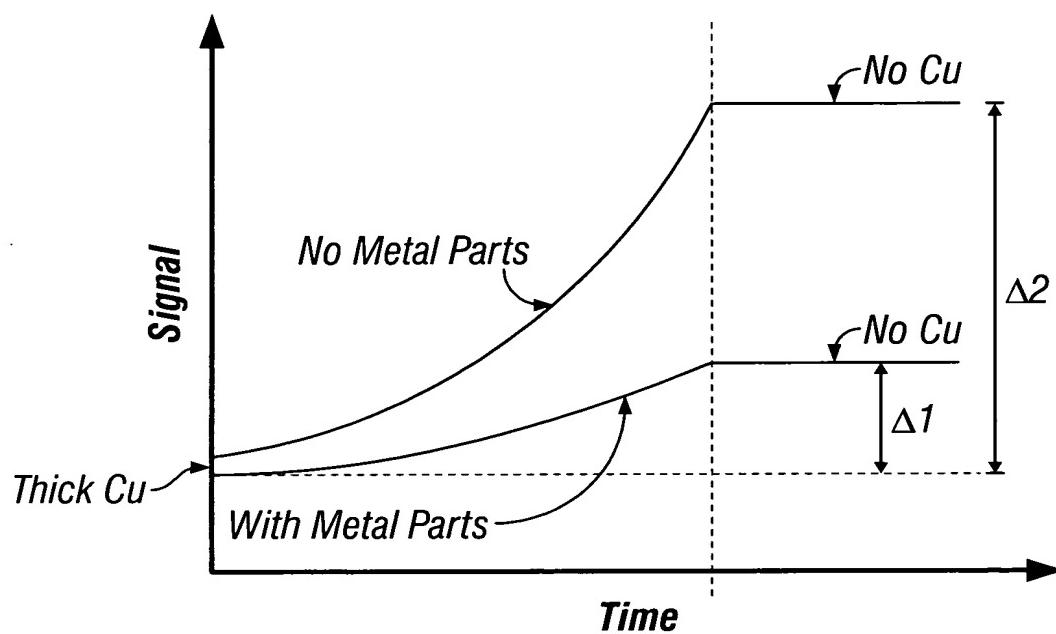


FIG. 14

**13/14****FIG. 15**

**14/14****FIG. 16**